



Docket No.: 0756-7197

17W

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

THIS PATENT application of)
Koichiro TANAKA)
Serial No. 10/664,916) Group Art Unit: 1722
Filed: September 22, 2003) Examiner: R. Kunemund
For: BEAM HOMOGENIZER AND LASER)
IRRADIATION APPARATUS AND METHOD OF)
MANUFACTURING SEMICONDUCTOR
DEVICE

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with
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[Signature]

REQUEST FOR STATUS

Honorable Commissioner of Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action on the
amendment filed November 22, 2006 in the above-identified patent application. Please
provide the undersigned with a status report of the application in writing.

Respectfully submitted,

[Signature]

Eric J. Robinson
Reg. No. 38,285

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